



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

WATANABE, Satoshi

Examiner: TRAN, Binh X.

Serial No.: 09/401,490

Group Art Unit: 1765

Filed: September 22, 1999

Title: RESIST COMPOSITION AND PATTERNING METHOD

REPLY

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 16, 2004, and the Interview of May 19, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.